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Temperature Dependent 4-, 5- and 6-fold Coordination of Aluminum in MOCVD-grown Amorphous Alumina Films: From Local Coordination to Material Properties

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Abstract. Aluminum 5-fold coordination coexisting with 4- and 6-fold coordination structurally characterizes amorphous aluminum oxide. For nearly 30 years now, 27Al MAS NMR has enabled to detect and later on to quantify this feature thanks to advances in high-resolution instrumentation. The Introduction shortly reviews the results of investigations of 5-coordinate aluminum in amorphous alumina through NMR analysis. Aluminum oxide is not a glass-forming oxide. A convenient way to obtain the amorphous state is by thin film deposition. We present here 27Al NMR analysis of a series of thin films of aluminum oxide prepared by metalorganic chemical vapor deposition (MOCVD) in the temperature range 360 ≤ Td ≤ 720 °C. In this range, low Td yield OH-containing films, while high Td yield nanocrystallites-containing films. The variation of the [4]Al, [5]Al and [6]Al content with Td is presented and discussed. It is correlated with the Td dependence of mechanical and corrosion protection properties. These properties are optimal when the structural disorder is to the utmost. Al coordination dependence on film thickness and the formation of metallic aluminum during the deposition process are also presented.

Introduction - Review of Pentacoordinate Aluminum in Aluminum Oxide

Like the stable form of aluminum oxide, α-Al2O3 (corundum), the crystal forms of aluminum hydroxides [bayerite α-Al(OH)3 and gibbsite γ-Al(OH)3] and oxyhydroxides [diaspore α-AlO(OH) and boehmite γ-AlO(OH)] have all of the aluminum ions in octahedral sites ([6]Al). In transition aluminum oxides (η-, θ-, γ-, δ-, χ-, κ-Al2O3), the aluminum ions occupy both tetrahedral [4]Al and octahedral [6]Al sites. Amorphous aluminas are characterized by the extra presence of pentacoordinate aluminum ions [5]Al beside [4]Al and [6]Al ones. Hereafter, we review results of studies about the distribution of these three Al coordination numbers in amorphous alumina according to sample type (massive, thin film, nanoparticle) and preparation conditions. Results are gathered in Table 1.

Solid-state MAS NMR is most appropriate to analyze aluminum coordination in non-crystalline or nano-crystalline solids. Evidence of penta-coordinate aluminum in amorphous alumina (α-Al2O3) was first reported by Dupree et al. in 1985 [1]. The authors worked on alumina anodic films which they submitted to 27Al solid-state MAS NMR with a spectrometer operating at 93.8 MHz. In order to have enough material, several films grown under the same conditions were stripped from the aluminum substrate and assembled into one sample [2, 3]. From the NMR lines corresponding to tetra-, penta- and hexa-coordination, the authors measured the following atom percentages for films
The presence of penta-coordinate aluminum in massive alumina was detected in 1991 through the $^{27}$Al MAS NMR analysis of the amorphous variety called ρ-Al₂O₃ [4]. This variety results from \textit{in vacuo} partial dehydration of gibbsite. It shows an ‘amorphous’ X-ray pattern [4], or ‘only a few diffuse lines in its X-ray powder diffraction pattern’ [5]. The respective atom percentages of $[4]$Al, $[5]$Al and $[6]$Al were quantified to 25, 20 and 55% [5]. At about the same time, Chen et al. published a study on aluminas obtained by calcining finely divided gibbsite and boehmite between 400 and 800°C. From $^{27}$Al MAS NMR, the ‘X-ray amorphous aluminas’ obtained from boehmite had the composition $[4]$Al $≈$ $[5]$Al = 27.5%, $[6]$Al = 45% for calcination temperature between 500 and 600 °C [6]. Those obtained from gibbsite were less stable, having the composition $[4]$Al = 30%, $[5]$Al = 10%, $[6]$Al = 60% for calcination temperature between 400 and 500 °C; above 600°C their $[5]$Al content decreased to about 6% at 600°C and it was below 3% at 700°C [6]. Kunath-Fandrei et al., still using $^{27}$Al MAS NMR, measured $[4]$Al = 22.5%, $[5]$Al = 7.5% and $[6]$Al = 70.0% for ‘an amorphous partially dehydrated alumina formed by calcining gibsite’ [7]. A small amount (ca. 5%) of $[5]$Al, supposedly surface species, was also reported for γ-Al₂O₃ formed upon thermal decomposition of boehmite (γ-AlOOH) [8-10].

Using $^{27}$Al MAS NMR experiments operating at a magnetic field of 9.4T, Lee et al. recently showed that two α-Al₂O₃ films grown by physical vapor deposition (PVD) [11] and atomic layer deposition (ALD) [12] mainly consist of tetra-coordinate and penta-coordinate aluminum sites with a low content of hexa-coordinate aluminum sites ($[4]$Al, 56 for PVD, 54 for ALD; $[5]$Al, 36 for PVD,
41 for ALD; $[^{6}]$Al, 7 for PVD, 5 for ALD; all in atom %). This was actually the first MAS NMR study for amorphous alumina thin films not detached from the substrate. The substrate was 200 µm thick silicon wafer. Powder samples for $^{27}$Al NMR analysis were prepared by grinding the coated substrate. To increase the Al/Si mass ratio, the authors reduced the thickness of the substrate down to 100 µm by chemically attacking the non-coated face. Incidentally, in this paper we report on an easier way to obtain NMR samples with acceptable Al/substrate mass ratio.

Very recently, Tavakoli et al. published results concerning amorphous alumina nanoparticles [13]. The nanoparticles were obtained by laser evaporating $\text{Al}_2\text{O}_3$ targets and condensing the vapor phase on a stainless-steel support. As-deposited nanoparticles and particles annealed at 600 °C were amorphous (XRD and TEM) and had average sizes of $3.6 \pm 0.4$ nm and $4.8 \pm 0.5$ nm respectively. From $^{27}$Al MAS NMR, the relative fractions for four-, five-, and six-coordinated Al ions were respectively 19, 67, and 14 at.% for as-deposited particles and 27, 54, and 19 at.% for nanoparticles annealed at 600 °C.

Five-coordinated aluminum is also present in liquid alumina. High-temperature NMR experiments revealed an average Al coordination number of about 4.5-4.9 [14-18]. The rapid exchange between the different aluminum coordination geometries results in one single NMR resonance peak, making the quantification of sites population less straightforward than in the solid state. The simultaneous presence of $[^{4}]$Al, $[^{5}]$Al and $[^{6}]$Al was confirmed through diffraction experiments combined with modeling approaches. The most recent of these studies shows that liquid alumina near its melting point is composed predominantly of $[^{4}]$Al and $[^{5}]$Al sites in the approximate ratio of 2:1, with minor fractions of $[^{3}]$Al and $[^{6}]$Al sites [19]. It is worth noting that metallic aluminum $\text{Al}^0$ was detected by NMR in a droplet of alumina rapidly cooled from the melt under inert atmosphere [17].

Having long processed thin films of aluminum oxide by metalorganic chemical vapor deposition (MOCVD), we have focused our interest in the relationship between processing conditions, structural features and properties of the films. MOCVD-processed alumina thin films are “X-ray amorphous” up to deposition temperature of 700 °C. Recently we published the results of a $^{27}$Al NMR study of a series of six amorphous thin films deposited in the temperature range 360-720 °C [20]. This was the first study on the influence of deposition temperature on aluminum coordination number. Thanks to the use of a very high field (20 T) spectrometer, the 1D and 2D spectra could be collected for the six samples in reasonably short lengths of time. The study was completed with the investigation of proton through $\{^{1}\text{H}\}^{27}$Al rotational echo double resonance (REDOR) for the samples containing OH groups. The details of this thorough NMR investigation are given in reference [20]. Here we focus on relationship between temperature of deposition, hydroxylation rate, order range, aluminum coordination numbers and some physical properties.

Experimental

Thin Films Preparation. The films examined in this study were grown in a custom-made, horizontal, hot-wall reactor described in a previous paper [21]. Supercooled ATI (Acros Organics) was heated at 90 °C and the vapor phase was carried to the deposition zone by bubbling with 99.9999% pure N$_2$ (Air Products). Fixed experimental parameters were as follows: total pressure, 0.67 kPa; N$_2$ flow rate over ATI, 20 standard cubic centimeters per minute (sccm); and dilution N$_2$ flow rate, 631 sccm. Film thickness was determined from weight gain of the samples and by reflectometry using a UV−VIS reflectometer (Ocean Optics) and NanoCalc software.

NMR Analysis

Samples for NMR. Six films with targeted thickness of 0.5 ± 0.1 µm were grown on 100 µm thick, (100) oriented silicon wafers at 360, 420, 480, 550, 600, and 720 °C. Three more samples with targeted thickness 0.1, 0.2, and 1 µm were prepared at 480 °C in order to gain insight into possible structural evolution along the thickness of the film. The samples, comprising the oxide film and the wafer, were then ground into a coarse powder for packing in the NMR sample container.
NMR experiments. Solid-state $^{27}$Al NMR experiments were carried out on a Bruker AVANCE III spectrometer operating at a magnetic field of 20.0 T (Larmor frequency of 221.5 MHz). The available volume for the powder sample in the 2.5 mm MAS probe head was 14 μL. Details about acquisition and treatment of one-dimensional (1D) MAS and two-dimensional (2D) MQMAS spectra are given in reference [20]. Among the four samples prepared at 480 °C, only the thickest one was submitted to 3QMAS NMR because the amount of aluminum for the thinnest films (i.e., the smallest ratio alumina/wafer) would necessitate unpractical experimental times. All spectra were referenced with respect to a 1 M solution of Al(NO$_3$)$_3$. 1D and 2D spectra were simulated using the Dmfit software [22].

Results

Composition and Amorphicity/Crystallinity of the Films. An important point is that there are two families of films according to whether they contain OH groups or not [23]. The films grown at 360 and 420 °C contain OH and are formulated AlO$_1$+$x$(OH)$_{1-2x}$, with $x$ increasing from 0 [AlO(OH) or O/Al = 2] to $\frac{1}{2}$ [Al$_2$O$_3$ or O/Al = 1.5]. For T$_d$ = 350 °C, the O/Al atomic ratio is 2. The films grown at 550, 600, and 720 °C are non-hydroxylated Al$_2$O$_3$. The temperature frontier between hydroxylated and non-hydroxylated films has not been ascertained. It is estimated at about 450 °C, so that the film grown at 480 °C can be considered as non-hydroxylated Al$_2$O$_3$.

In previous studies [21], we established that the films processed in the temperature range 350–550 °C show no XRD lines, and that those grown at 700 °C show wide, ill-defined diffraction peaks corresponding to $\gamma$-Al$_2$O$_3$. Well-crystallized $\gamma$-Al$_2$O$_3$ forms upon annealing for 1 h at 800 °C under nitrogen flow. We also observed in the TEM that a film grown at 700 °C is embedded with nanocrystals of $\gamma$-Al$_2$O$_3$ while no such crystals form in a film grown at 550°C [23]. Therefore, the samples presented here can be classified into three categories: amorphous hydroxylated alumina (a-AlO$_1$+$x$(OH)$_{1-2x}$) for T$_d$ = 360 and 420 °C; amorphous non-hydroxylated alumina (a-Al$_2$O$_3$) for T$_d$ = 480, 550 and 600 °C; amorphous non-hydroxylated alumina embedded with nanocrystals of $\gamma$-Al$_2$O$_3$ (a-Al$_2$O$_3$ + $\gamma$-Al$_2$O$_3$) for T$_d$ = 720 °C.

Aluminum coordination. As illustrations of the quality of the NMR spectra, Figure 1 shows the 1D quantitative $^{27}$Al spectra and the 2D 3QMAS $^{27}$Al spectra for the films grown at 420, 550 and 720°C. The spectral resolution resulting from the very high magnetic field (20 T) allows a clear identification of the tetra-, penta-, and hexa-coordinated aluminum sites ($[^n]$Al with n = 4, 5, or 6). Their line shapes are characteristic of a typical amorphous structure as seen in alumina-containing glasses [22]. The simulation of such NMR spectra is based on the “Czjzek” model (or Gaussian isotropic model) [24-26]. The NMR parameters deduced from this model are the averaged isotropic chemical shift (δ$_{iso}$), the chemical shift distribution (ACS), and the averaged quadrupolar constant (CQ). As shown recently [27] for $^{27}$Al, δ$_{iso}$ is mainly governed by chemical modifications in the second coordination sphere, while CQ measures the distortion (bond lengths and/or angles) of the AlO$_n$ polyhedrons in which the Al-O bonds have some covalent character, that is the AlO$_4$ tetrahedra mainly. ACS measures the amount of disorder, in other words the width of the bond angle and bond distances distributions. It broadens the NMR lines in such a way that it is difficult to disentangle it from the broadening due to the distribution of CQ without the help of a 2D experiment spreading the information in a second dimension.

As the 3QMAS spectra have fully separated the three $[^n]$Al sites (Figure 1), they were first simulated in order to obtain primary sets of optimized values of δ$_{iso}$, ACS and CQ [20]. The 1D $^{27}$Al MAS spectra were reconstructed by optimizing nine parameters (δ$_{iso}$, CQ, amplitude) while keeping the ACS values as issued from the 3QMAS experiment. The percentages of each $[^n]$Al site was calculated from line shape integration of the central transition. The optimized values are in Table 1.
Figure 1. $^{27}$Al NMR spectra for films deposited at 420, 550 and 720 °C. Left: experimental (dots) and reconstructed (red) 1-D MAS spectra of the central transitions of the three $^{[n]}$Al sites. The grey lines refer to the contributions to the reconstructed spectra. Asterisks show the spinning sidebands of the external transitions. The center bands were simulated with Gaussian line shapes accounting for the line widths and intensities of their neighboring sidebands. Right: experimental and simulated (red) 2-D $^{27}$Al 3QMAS spectra of the films. The full set of spectra relative to this study is given in reference [20].

Figure 2 shows the evolution of the percentages of $^{[n]}$Al sites and of ΔCS with $T_d$. The respective percentages of tetra- and hexa-coordinated sites vary with opposite trends. The $^{[4]}$Al content increases from 33% for $T_d = 360$ °C up to 53% for $T_d = 480$ °C; at the same time, the $^{[6]}$Al content decreases from 26% to 5%. For $T_d = 550$ °C, the respective percentages have values that are nearly the same as those for 480 °C, suggesting that the maximum of $^{[4]}$Al sites and the minimum of $^{[6]}$Al sites occur for $T_d \sim 515$ °C. From 360 to 515 °C, the $^{[5]}$Al content is at its highest with values between 40% and 43%. It can be noticed that the $^{[n]}$Al percentages measured for $T_d = 480$ °C (and 550 °C) compare well with those measured by Lee et al. for two aluminum oxide films prepared by PVD and ALD [11, 12] (Table 1). In the 550–720 °C range, the $^{[6]}$Al content increases to 59% and the $^{[4]}$Al and $^{[5]}$Al contents decrease to 29% and 12%, respectively.

The average isotropic chemical shift $\bar{\delta}_{iso}$ does not present any significant evolution with $T_d$, consistent with the fact that there are no chemical variations in the aluminum second coordination sphere (i.e., only Al atoms) [20]. The average values of $C_Q$ and ΔCS between the three $^{[n]}$Al sites show the same hierarchy whatever the temperature of deposition: $C_Q^{(4)}Al > C_Q^{(5)}Al > C_Q^{(6)}Al$ and ΔCS($^{[4]}$Al) > ΔCS($^{[5]}$Al) > ΔCS($^{[6]}$Al) [20]. The same $C_Q$ trend was observed for rare-earth
aluminosilicates [28, 29] and may be related to polyhedra-specific distortions. Figure 2 shows that
\( \Delta CS \) is maximal for a \( T_d \) half-way between 480 and 550 °C for each coordination number. This
suggests that the utmost structural disorder corresponds to the highest rates of \([4]Al\) and \([5]Al\) sites.

The average coordination number \( CN_{av.} = \frac{[4](4)Al\ at.\% + 5([5]Al\ at.\% + 6([6]Al\ at.\%)]}{100}, \)
decreases from 4.93 for \( T_d = 360 \) °C down to 4.50 for \( T_d \sim 515 \) °C, and then increases up to 5.31 for
\( T_d = 720 \) °C.

**Figure 2.** Atom percentages of \([4]Al\) (squares) \([5]Al\) (circles) and \([6]Al\) (triangles) sites (top) and the
corresponding chemical shift distributions (bottom) versus deposition temperature. Lines are a guide to the eye.

**Figure 3.** Hardness (top) and Young’s modulus (bottom) measured for alumina films grown at
different temperatures. The substrate was Ti6Al4V for the films grown at 350, 480 and 700 °C and
silicon for the films grown at 415 and 600 °C. Lines are a guide to the eye.

**Mechanical properties.** Hardness and Young’s modulus were calculated from nanoindentation
measurements for three films deposited on commercial Ti6Al4V titanium alloy at 350, 480 and 700
°C, and two films deposited on silicon at 415 and 600 °C [30]. Figure 3 shows hardness and
Young’s modulus variations with the temperature of deposition. There is a striking apparent relation
with the variations of \([n]Al\) atom %. Both properties increase nearly linearly with the temperature
between 360 and 480 °C, reach a plateau or a flattened maximum between 500 and 600 °C, and
decrease abruptly between 600 and 700 °C.

The films grown at 350 and 415 °C contain OH groups, with respective atomic ratios O/Al about
2.0 and 1.6. The respective Young’s moduli are 92 and 133 GPa, showing an increase with
decreasing OH content. This agrees with results obtained by Kijima and Hanada [31] for diversely
hydroxylated (1.55 < O/Al < 1.75) amorphous alumina films deposited by rf-sputtering. They
observed a linear dependence of Young’s modulus on the atomic ratio O/Al. However their values
were smaller than in the present study, for instance 75 and 115 GPa for O/Al = 1.75 and 1.60
respectively. The extrapolated value for O/Al = 1.5 was 141 GPa, to be compared with 155 GPa in
the present study for the film grown at 480 °C.
The values measured for the film grown at 415°C (H = 7.8 GPa, E = 133 GPa) in the present study compare with those reported by Alcala et al. for an amorphous anodic alumina film: H = 7.0 GPa, E = 122 GPa [32]. Amorphous anodic alumina is known to contain OH [2, 3].

The hardness (11.2 GPa) and Young’s modulus (175 GPa) of the film grown at 600 °C compare with those measured by Nakao et al. for a 600 nm thick film grown on Si(100) by rf-sputtering (11.0 and 181 GPa respectively) [33]. They also compare with values measured by Barbour et al. for several hundred nm thick films deposited on Si(100) at varied temperatures using electron-beam evaporation of aluminum and co-bombardment with O2+ ions from an electron-cyclotron resonance plasma (11.1 and 187 GPa at 400 °C; 9.6 and 177 GPa at 170 °C; 9.5 and 170 GPa at 145 °C) [34].

Interesting with respect to the present study, Natali et al. measured the hardness and Young’s modulus of three films of non-hydroxylated amorphous alumina prepared by the MOCVD technique at 380 °C and annealed at 500 and 700 °C [35]. Hardness values of 10.9, 11.9 and 10.6 GPa for the preparation or annealing temperatures of 380, 500 and 700 °C respectively compare quite well with those for the films obtained at 480 °C (10.8 GPa) and 600 °C (11.2 GPa) in the present study. The corresponding Young’s modulus (184.3, 198.3 and 178.9 GPa) are slightly larger than the larger ones in the present study. However it is worth noting that the highest values in Natali et al.’s study (H = 11.9 GPa, E = 198.3 GPa) are observed for the film annealed at 500 °C, that is on the plateau evidenced in the present study. On the contrary, the film annealed at 700 °C in Natali et al.’s work (H = 10.6 GPa, E = 178.9 GPa) behaves quite differently from the one grown at 700 °C in the present study (H ~ 1 GPa, E ~ 10 GPa).

**Protection against corrosion.** To study corrosion protection, thin films of alumina were deposited at 350, 480 and 700 °C [36] or 750 °C [37] on Ti6Al4V titanium alloy. Polarization curves in a 0.1 M NaCl solution showed that the lowest corrosion potential corresponded to the film deposited at 350 °C and was close to that of the bare alloy. This film resulted also in the highest anodic and cathodic current densities. The films deposited at 480 and 700 or 750 °C gave higher corrosion potentials. Moreover the film deposited at 480 °C gave lower anodic and cathodic current densities that the ones deposited at 700 and 750 °C. So the polarization curves in a 0.1 M NaCl solution clearly showed that the amorphous Al2O3 film deposited at 480 °C gave better corrosion protection than the amorphous AIO(OH) film deposited at 350 °C or the partially nanocrystallized Al2O3 films deposited at 700 and 750 °C. Electrical impedance measured after 1 h in the NaCl solution showed that the film deposited at 480 °C improved corrosion resistance by nearly 2 orders of magnitude: the impedance moduli measured at 20 Mhz were 2.3×10^7 Ω·cm² and 7.4×10^5 Ω·cm² for Td = 480 °C to compare with 3.6×10^5 Ω·cm² and 7.4×10^5 Ω·cm² for Td = 350 °C and 750 °C respectively [37]. Electrochemical impedance spectroscopy was also applied to films deposited on 304L stainless steel at 480 °C [38]. The good barrier properties of the alumina films deposited at 480 °C were confirmed. They improve significantly on increasing the thickness up to a threshold of ca. 500-600 nm.

**Formation of metallic aluminum Al.** Figure 4 shows the 1D quantitative 27Al spectrum in the frequency range 1400-1800 ppm for a 85 nm thick film processed at Td = 480 °C. The spectrum clearly reveals a peak at 1650 ppm corresponding to metallic aluminum Al0. The film belongs to a series of four deposits processed at 480 °C with varying thickness: 85, 180, 600, and 940 nm. The aim was to gain insight into possible structural evolution along deposited alumina thickness. The presence of metallic aluminum was unexpected. The unexpected peak at 1650 ppm did not show up on a 1D 27 Al spectrum recorded with the bare silicon substrate. Moreover, its relative intensity decreased (0.018, 0.010, 0.003) with increasing thickness (85, 180, 600 nm) [20]. These two observations lead to the conclusion that metallic aluminum does form during alumina growth, and that it forms as a very thin layer at the silicon/alumina interface. As reminded in the Introduction, metallic aluminum was detected by NMR in a droplet of alumina rapidly cooled from the melt (∼2350 °C) under inert atmosphere [17]. Here also alumina was processed under inert atmosphere (99.9992% pure N2), but the temperature was ∼2000 degrees lower.
Film Thickness Dependence of the Structure. The NMR analysis of the four films deposited at 480 °C with varying thickness shows that the distribution of $^{[6]}$Al sites is slightly different in the thinnest film (85 nm) comparatively to the three thicker ones (180, 600, 936 nm). The percentages of $^{[6]}$Al sites do not differ significantly with increasing thickness: 5.6 ± 0.9, 5.3 ± 0.7, 5.4 ± 0.4, 4.6 ± 0.9 %. But the corresponding values for $^{[5]}$Al and $^{[4]}$Al are respectively: 43.7 ± 0.7, 41.0 ± 0.6, 41.6 ± 0.4, 41.8 ± 0.7%, and 50.7 ± 1.0, 53.7 ± 0.8, 53.0 ± 0.6, 53.6 ± 0.6%. Compared to the thicker films, the thinner one contains a little excess of $^{[5]}$Al sites and a little deficit of $^{[4]}$Al sites. Although formally significant, these variations may be questioned. They might sign a size effect. Tavakoli et al. observed that the large amount of 67% of $^{[5]}$Al sites in as-deposited amorphous alumina nanoparticles having an average size of 3.6 nm dropped down to 54% when the average size increased to 4.8 nm upon heating at 600 °C. In the same time, the respective percentages of $^{[4]}$Al and $^{[6]}$Al sites increased from 19 to 27 and from 14 to 19 [13]. The observed changes in $^{[5]}$Al and $^{[4]}$Al contents in the 85 nm thick film might well be the starting of the increasing amorphous character of the deposit for very weak thickness.

Concluding remarks. The “most amorphous structure” is that of Al$_2$O$_3$ grown between 480 and 550 °C. This structure is the less propitious to grain boundary formation. Moreover, it corresponds to the minimal average coordination number (~4.50), hence the most covalent character of the structure. These are key features for the mechanical and diffusion barrier properties of alumina. Further studies are needed to be more specific about the structure-properties relationship.

The collapse of hardness and elastic modulus between 600 and 700 °C might result from the formation of a biphasic amorphous/crystalline structure. It is recalled that embedded nanocrystals of $\gamma$-Al$_2$O$_3$ were observed in the TEM for $T_d = 700$ °C while there were no such crystals in a film grown at 550°C [23]. The structure of $\gamma$-Al$_2$O$_3$ is made of tetrahedral $^{[4]}$Al and octahedral $^{[6]}$Al sites in the atomic ratio $^{[6]}$Al,$^{[4]}$Al ≥ 2. This ratio (Table 1) is equal to 0.1 and 0.3 for $T_d = 550$ and 600 °C respectively: for lack of octahedral Al ions, $\gamma$-Al$_2$O$_3$ cannot form at these temperatures. The ratio rapidly increases up to ~1 at about 660 °C and ~2 at about 700 °C. The decreasing content in $^{[5]}$Al is still 12% at 720 °C. All of this is consistent with the spread formation of nanocrystals of $\gamma$-Al$_2$O$_3$ in the amorphous phase resulting in a biphasic structure for $T_d > 600$ °C.

References.


